IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: SINGH, et al.

RECEIVED

Application No.:

10/081,979

Examiner:

JUN 0 6 2002

Date Filed:

February 22, 2002

Group:

TC 1700

For:

IMPROVED CHEMICAL-MECHANICAL POLISHING SLURRY FOR

POLISHING OF COPPER OR SILVER FILMS

CERTIFICATE UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class mail in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231, on

Neil R. Jetter

Reg. No. 46,803

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicants hereby notify the U.S. Patent and Trademark Office of the documents which are listed on the attached Form PTO-1449 which the Examiner may deem relevant to patentability of the claims of the above-identified application.

The submission of the listed documents is not intended as an admission that the documents constitute prior art against the claims of the present application.

Applicants do not waive any rights to take any action that would be appropriate to antedate or otherwise remove the listed documents as a competent reference wpo89925;1

against the claims of the present application.

Applicants respectfully request that the listed documents be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO-1449 be returned in accordance with MPEP §609.

Although no fee is believed due, the Commissioner is hereby authorized to charge any fees which may be required by submission of these papers to Deposit Account No. 50-0951.

Respectfully submitted,

AKERMAN SENTERFITT & EIDSON, P.A.

Dated: 5/28/02

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Docket No. 5853-223